

Notice of References Cited	Application/Control No. 10/577,069		Applicant(s)/Patent Under Reexamination HATA ET AL.	
	Examiner JULIA SLUTSKER		Art Unit 2891	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,040,849 A	08-1977	Greskovich et al.	423/348
*	B	US-6,562,648 B1	05-2003	Wong et al.	438/46
*	C	US-7,547,925 B2	06-2009	Wong et al.	257/103
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	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.